Application/Control No.	Applicant(s)/Patent under Reexamination	
10/567,629	VADDE ET AL.	•
Examiner	Art Unit	
Jason M. Perilla	2611	

	SEARCHED				
Class	Subclass	Date	Examiner		
375	295	4/19/2007 ·	JP		
	146	4/19/2007	. Jb		
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Inventor Name Search East/EDAN	4/18/2007	JP				
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